

Handbook Of Optical Metrology

The purpose of this third edition is to bring together in a single book descriptions of all tests carried out in the optical shop that are applicable to optical components and systems. This book is intended for the specialist as well as the non-specialist engaged in optical shop testing. There is currently a great deal of research being done in optical engineering. Making this new edition very timely.

The measurement and characterisation of surface topography is crucial to modern manufacturing industry. The control of areal surface structure allows a manufacturer to radically alter the functionality of a part. Examples include structuring to effect fluidics, optics, tribology, aerodynamics and biology. To control such manufacturing methods requires measurement strategies. There is now a large range of new optical techniques on the market, or being developed in academia, that can measure areal surface topography. Each method has its strong points and limitations. The book starts with introductory chapters on optical instruments, their common language, generic features and limitations, and their calibration. Each type of modern optical instrument is described (in a common format) by an expert in the field. The book is intended for both industrial and academic scientists and engineers, and will be useful for undergraduate and postgraduate studies.

Containing more than 300 equations and nearly 500 drawings, photographs, and micrographs, this reference surveys key areas such as optical measurements and in-line calibration methods. It describes cleanroom-based measurement technology used during the manufacture of silicon integrated circuits and covers model-based, critical dimension, overlay

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This is the third volume of the very successful set. This updated volume will contain non-linear properties of some of the most useful materials as well as chapters on optical measurement techniques. Contributors have decided the best values for n and k References in each critique allow the reader to go back to the original data to examine and understand where the values have come from Allows the reader to determine if any data in a spectral region needs to be filled in Gives a wide and detailed view of experimental techniques for measuring the optical constants n and k Incorporates and describes crystal structure, space-group symmetry, unit-cell dimensions, number of optic and acoustic modes, frequencies of optic modes, the irreducible representation, band gap, plasma frequency, and static dielectric constant Written by the leading authority in the subject, Handbook of Surface Metrology covers every conceivable aspect of measuring and characterizing a surface. Focusing both on theory and practice, the book provides useful guidelines for the design of precision instruments and presents data on the functional importance of surfaces. It also clearly explains the essential theory relevant to surface metrology. The book defines most terms and parameters according to national and international standards. Many examples and illustrations are drawn from the esteemed author's large fund of groundbreaking research work. This unparalleled, all-encompassing "metrology bible" is beneficial for engineering postgraduate students and researchers involved in tribology, instrumentation, data processing, and metrology. A coherent overview of the current status of injection molded optics, describing in detail all aspects of plastic optics, from design issues to production technology and quality control. This updated second edition is supplemented by a chapter on the equipment and process of injection wells as well as a look at recent applications. The contributors, each one a leading

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expert in their discipline, have either a background in or strong ties to the industry, thus combining a large amount of practical experience. With its focus firmly set on practical applications, this is an indispensable reference for all those working in optics research and development.

Optical systems have a wide range of technical applications (e.g. viewing devices, lens systems) and uses in industrial manufacturing. And while the design of optical systems requires a high level of expertise, there is, to date, no resource available, which allows beginners to learn optical design. This state-of-the-art handbook, written by reputed industrial experts, provides a comprehensive introduction to designing optical systems, combining for the first time theoretical aspects of optical modeling with applications of practical optical design. With more than 3,000 full-colored illustrations and images, here is an essential reference for the optical industry as well as universities of applied sciences.

The book presents the principles and methods of holographic interferometry - a coherent-optical measurement technique for deformation and stress analysis, for the determination of refractive-index distributions, or applied to non-destructive testing. Emphasis of the book is on the quantitative computer-aided evaluation of the holographic interferograms. Based upon wave-optics the evaluation methods, their implementation in computer-algorithms, and their applications in engineering are described.

Increased demand for and developments in micromanufacturing have created a need for a resource that covers both the science and technology of this rapidly growing area. With contributions from eminent professors and researchers actively engaged in teaching, research, and development, *Micromanufacturing Processes* details the basic principles, tools,

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This Springer Handbook of Metrology and Testing presents the principles of Metrology – the science of measurement – and the methods and techniques of Testing – determining the characteristics of a given product – as they apply to chemical and microstructural analysis, and to the measurement and testing of materials properties and performance, including modelling and simulation. The principal motivation for this Handbook stems from the increasing demands of technology for measurement results that can be used globally. Measurements within a local laboratory or manufacturing facility must be able to be reproduced accurately anywhere in the world. The book integrates knowledge from basic sciences and engineering disciplines, compiled by experts from internationally known metrology and testing institutions, and academe, as well as from industry, and conformity-assessment and accreditation bodies. The Commission of the European Union has expressed this as there is no science without measurements, no quality without testing, and no global markets without standards. The field of optical metrology offers a wealth of both practical and theoretical accomplishments, and can cite any number of academic papers recording such. However, while several books covering specific areas of optical metrology do exist, until the pages herein were researched, written, and compiled, the field lacked for a comprehensive handbook, one providing an overview of optical metrology that covers practical applications as well as fundamentals. Carefully designed to make information accessible to beginners without sacrificing academic rigor, the Handbook of Optical Metrology: Principles and Applications discusses fundamental principles and techniques before exploring practical applications. With contributions from veterans in the field, as well as from up-and-coming researchers, the Handbook offers 30 substantial and well-referenced chapters. In addition to the introductory matter, forward-

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thinking descriptions are included in every chapter that make this a valuable reference for all those involved with optical metrology.

Proceedings of SPIE present the original research papers presented at SPIE conferences and other high-quality conferences in the broad-ranging fields of optics and photonics. These books provide prompt access to the latest innovations in research and technology in their respective fields. Proceedings of SPIE are among the most cited references in patent literature.

As we reach the data transmission limits of copper wire and communications experts seek to bring the speed of long-haul fiber optics networks closer to access points, optical interconnects promise to provide efficient, high-speed data transmission for the next generation of networks and systems. They offer higher bit-rates, virtually no crosstalk, lower demands on power requirements and thermal management, and the possibility of two-dimensional channel arrays for chip-to-chip communication. The Handbook of Optical Interconnects introduces the systems and devices that will bring the speed and quality of optical transmission closer to the circuit board. Contributed by active experts, most from leading technology companies in the US and Japan, this outstanding handbook details various low-cost and small-size configurations, illustrates the discussion with more than 300 figures, and offers a look at the applications and future of this exciting and rapidly growing field. The book includes a detailed introduction to vertical cavity surface-emitting lasers (VCSELs); the use of optical interconnects in metropolitan, local-area, and access networks through FTTP (FTTH); and Jisso technologies, which are critical for developing low-cost, small-size modules. Driving down the size and cost of optical interconnects is vital for integrating these technologies into the network and onto microprocessors, and the Handbook of Optical Interconnects provides the knowledge and tools

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necessary to accomplish these goals.

A comprehensive review of the state of the art and advances in the field, while also outlining the future potential and development trends of optical imaging and optical metrology, an area of fast growth with numerous applications in nanotechnology and nanophysics. Written by the world's leading experts in the field, it fills the gap in the current literature by bridging the fields of optical imaging and metrology, and is the only up-to-date resource in terms of fundamental knowledge, basic concepts, methodologies, applications, and development trends.

A one-stop, concise guide on determining and measuring thin film thickness by optical methods. This practical book covers the laws of electromagnetic radiation and interaction of light with matter, as well as the theory and practice of thickness measurement, and modern applications. In so doing, it shows the capabilities and opportunities of optical thickness determination and discusses the strengths and weaknesses of measurement devices along with their evaluation methods. Following an introduction to the topic, Chapter 2 presents the basics of the propagation of light and other electromagnetic radiation in space and matter. The main topic of this book, the determination of the thickness of a layer in a layer stack by measuring the spectral reflectance or transmittance, is treated in the following three chapters. The color of thin layers is discussed in chapter 6. Finally, in chapter 7, the author discusses several industrial applications of the layer thickness measurement, including high-reflection and anti-reflection coatings, photolithographic structuring of semiconductors, silicon on insulator, transparent conductive films, oxides and polymers, thin film photovoltaics, and heavily doped silicon. Aimed at industrial and academic researchers, engineers, developers and manufacturers involved in all areas of optical layer and thin optical film measurement and

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metrology, process control, real-time monitoring, and applications.

Nineteen Fact-Filled Charters that contain authoritative treatment of all aspects of dimensional measurement technology make Handbook of Dimensional Measurement the most readable and comprehensive guide available for engineers and technicians engaged in the various stages of industrial production. Design engineers, manufacturing engineers, tool and gage makers, quality control specialists, and reliability experts will find a wealth of practical data as well as complete coverage - both basic and advanced - of dimensional measurement techniques and equipment. The Third Edition of this classic book has been completely revised to include the computer and electronics revolution in metrology. Virtually every type of measurement instrument and machine, even the newest devices, can be found in these pages. Hundreds of changes, and additions and scores of new illustrations have been incorporated to assure that Handbook of Dimensional Measurement retains its status as the standard reference for the practitioner of dimensional measurement.

This new edition of the bestselling Measurement, Instrumentation, and Sensors Handbook brings together all aspects of the design and implementation of measurement, instrumentation, and sensors. Reflecting the current state of the art, it describes the use of instruments and techniques for performing practical measurements in engineering, physics, chemistry, and the life sciences; explains sensors and the associated hardware and software; and discusses processing systems, automatic data acquisition, reduction and analysis, operation

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characteristics, accuracy, errors, calibrations, and the incorporation of standards for control purposes. Organized according to measurement problem, the Second Edition: Consists of 2 volumes Features contributions from 240+ field experts Contains 53 new chapters, plus updates to all 194 existing chapters Addresses different ways of making measurements for given variables Emphasizes modern intelligent instruments and techniques, human factors, modern display methods, instrument networks, and virtual instruments Explains modern wireless techniques, sensors, measurements, and applications A concise and useful reference for engineers, scientists, academic faculty, students, designers, managers, and industry professionals involved in instrumentation and measurement research and development, Measurement, Instrumentation, and Sensors Handbook, Second Edition provides readers with a greater understanding of advanced applications.

Optical Metrology for Fluids, Combustion and Solids is the first practical handbook that presents the assemblage of the techniques necessary to provide a basic understanding of optical measurement for fluids, combustion, and solids. The use of light as a measurement tool has grown over the past twenty years from a narrowly specialized activity to a mainstay of modern research today. Until recently, the knowledge that could be extracted from the light interaction of light

with physical objects was limited to specialized activities. The invention of the laser, the computer and microelectronics has enabled a measurement revolution such that virtually every parameter of engineering interest can be measured using the minimally intrusive properties of light. The authors of this book's chapters are leaders in this revolution. They work on the front lines of research in government, industry, and universities, inventing yet more ways to harness the power of light for the generation of knowledge.

Retaining the comprehensive and in-depth approach that cemented the bestselling first edition's place as a standard reference in the field, the Handbook of Semiconductor Manufacturing Technology, Second Edition features new and updated material that keeps it at the vanguard of today's most dynamic and rapidly growing field. Iconic experts Robert Doering and Yoshio Nishi have again assembled a team of the world's leading specialists in every area of semiconductor manufacturing to provide the most reliable, authoritative, and industry-leading information available. Stay Current with the Latest Technologies In addition to updates to nearly every existing chapter, this edition features five entirely new contributions on... Silicon-on-insulator (SOI) materials and devices Supercritical CO₂ in semiconductor cleaning Low- ϵ dielectrics Atomic-layer deposition Damascene copper electroplating Effects of terrestrial radiation on

integrated circuits (ICs) Reflecting rapid progress in many areas, several chapters were heavily revised and updated, and in some cases, rewritten to reflect rapid advances in such areas as interconnect technologies, gate dielectrics, photomask fabrication, IC packaging, and 300 mm wafer fabrication. While no book can be up-to-the-minute with the advances in the semiconductor field, the Handbook of Semiconductor Manufacturing Technology keeps the most important data, methods, tools, and techniques close at hand.

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The fourth volume of this popular Book Series is devoted to optics, lasers and optical sensors, and written by 29 authors from academia and industry from 10 countries: Brazil, China, France, Germany, Greece, Israel, Russia, Serbia, USA and Vietnam. This book ensures that the readers will stay at the cutting edge of the field and get the right and effective start point and road map for the further researches and developments. By this way, they will be able to save more time for productive research activity and eliminate routine work.

This book offers a genuinely practical introduction to the most commonly encountered optical and non-optical systems used for the metrology and characterization of surfaces, including guidance on best practice, calibration, advantages and disadvantages, and interpretation of results. It enables the user

to select the best approach in a given context. Most methods in surface metrology are based upon the interaction of light or electromagnetic radiation (UV, NIR, IR), and different optical effects are utilized to get a certain optical response from the surface; some of them record only the intensity reflected or scattered by the surface, others use interference of EM waves to obtain a characteristic response from the surface. The book covers techniques ranging from microscopy (including confocal, SNOM and digital holographic microscopy) through interferometry (including white light, multi-wavelength, grazing incidence and shearing) to spectral reflectometry and ellipsometry. The non-optical methods comprise tactile methods (stylus tip, AFM) as well as capacitive and inductive methods (capacitive sensors, eddy current sensors). The book provides: Overview of the working principles Description of advantages and disadvantages Currently achievable numbers for resolutions, repeatability, and reproducibility Examples of real-world applications A final chapter discusses examples where the combination of different surface metrology techniques in a multi-sensor system can reasonably contribute to a better understanding of surface properties as well as a faster characterization of surfaces in industrial applications. The book is aimed at scientists and engineers who use such methods for the measurement and characterization of surfaces across a wide

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range of fields and industries, including electronics, energy, automotive and medical engineering.

With the ongoing release of 3D movies and the emergence of 3D TVs, 3D imaging technologies have penetrated our daily lives. Yet choosing from the numerous 3D vision methods available can be frustrating for scientists and engineers, especially without a comprehensive resource to consult. Filling this gap, Handbook of 3D Machine Vision: Optical Metro

Despite a number of books on biophotonics imaging for medical diagnostics and therapy, the field still lacks a comprehensive imaging book that describes state-of-the-art biophotonics imaging approaches intensively developed in recent years.

Addressing this shortfall, Advanced Biophotonics: Tissue Optical Sectioning presents contemporary methods and applications of biophotonics imaging.

Gathering research otherwise scattered in numerous physical, chemical, biophysical, and biomedical journals, the book helps researchers, bioengineers, and medical doctors understand major recent bioimaging technologies and the underlying biophotonics science. Well-known international experts explore a variety of "hot" biomedical optics and biophotonics problems, including the use of photoacoustic imaging to investigate the molecular and cellular processes in living systems. The book also covers Monte Carlo modeling, tissue optics and

tissue optical clearing, nonlinear optical microscopy, various aspects of optical coherence tomography, multimodal tomography, adaptive optics, and signal imaging. With 58 color images, this book represents a valuable contribution to the biomedical and biophotonics literature. Designed for researchers and practitioners in biophotonics, the book is also a useful resource for scientists in laser physics and technology, fiber optics, spectroscopy, materials science, biology, and medicine as well as students studying biomedical physics and engineering, biomedical optics, and biophotonics.

The main objective of this book is to present the basic theoretical principles and practical applications for the classical interferometric techniques and the most advanced methods in the field of modern fringe pattern analysis applied to optical metrology. A major novelty of this work is the presentation of a unified theoretical framework based on the Fourier description of phase shifting interferometry using the Frequency Transfer Function (FTF) along with the theory of Stochastic Process for the straightforward analysis and synthesis of phase shifting algorithms with desired properties such as spectral response, detuning and signal-to-noise robustness, harmonic rejection, etc.

Due to the development of microscale fabrication methods, microlenses are being used more and more in many unique applications, such as artificial implementations of

compound eyes, optical communications, and labs-on-chips. Liquid microlenses, in particular, represent an important and growing research area yet there are no books devoted to this topic that summarize the research to date. Rectifying this deficiency, *Microlenses: Properties, Fabrication and Liquid Lenses* examines the recent progress in the emerging field of liquid-based microlenses. After describing how certain problems in optics can be solved by liquid microlenses, the book introduces the physics and fabrication methods involved in microlenses. It also details the facility and equipment requirements for general fabrication methods. The authors then present examples of various microlenses with non-tunable and tunable focal lengths based on different mechanisms, including: Non-tunable microlenses: Ge/SiO₂ core/shell nanolenses, glass lenses made by isotropic etching, self-assembled lenses and lens arrays, lenses fabricated by direct photo-induced polymerization, lenses formed by thermally reflowing photoresist, lenses formed from inkjet printing, arrays fabricated through molding processes, and injection-molded plastic lenses Electrically tuned microlenses: liquid crystal-based lenses and liquid lenses driven by electrostatic forces, dielectrophoretic forces, electrowetting, and electrochemical reactions Mechanically tunable microlenses: thin-membrane lenses with varying apertures, pressures, and surface shapes; swellable hydrogel lenses; liquid–liquid interface lenses actuated by environmentally stimuli-responsive hydrogels; and oscillating lens arrays driven by sound waves Horizontal microlenses: two-dimensional polymer lenses, tunable and movable liquid

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droplets as lenses, hydrodynamically tuned cylindrical lenses, liquid core and liquid cladding lenses, air–liquid interface lenses, and tunable liquid gradient refractive index lenses The book concludes by summarizing the importance of microlenses, shedding light on future microlens work, and exploring related challenges, such as the packaging of systems, effects of gravity, evaporation of liquids, aberrations, and integration with other optical components.

This handbook explains principles, processes, methods, and procedures of optical engineering in a concise and practical way. It emphasizes fundamental approaches and provides useful formulas and step-by-step worked-out examples to demonstrate applications and clarify calculation methods. The book covers refractive, reflective, and diffractive optical components; lens optical devices; modern fringe pattern analysis; optical metrology; Fourier optics and optical image processing; electro-optical and acousto-optical devices; spatial and spectral filters; optical fibers and accessories; optical fabrication; and more. It includes over 2,000 tables, flow charts, graphs, schematics, drawings, photographs, and mathematical expressions.

In the oil and gas industries, large companies are endeavoring to find and utilize efficient structural health monitoring methods in order to reduce maintenance costs and time. Through an examination of the vibration-based techniques, this title addresses theoretical, computational and experimental methods used within this trend. By providing comprehensive and up-to-date coverage of established and emerging

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processes, this book enables the reader to draw their own conclusions about the field of vibration-controlled damage detection in comparison with other available techniques. The chapters offer a balance between laboratory and practical applications, in addition to detailed case studies, strengths and weakness are drawn from a broad spectrum of information. Contents: Machine Learning Algorithms for Damage Detection (Eloi Figueiredo and Adam Santos)Data-Driven Methods for Vibration-Based Monitoring Based on the Singular Spectrum Analysis (Irina Trendafilova, David Garcia and Hussein Al-Bugharbee)Experimental Investigation of Delamination Effects on Modal Damping of a CFRP Laminate, Using a Statistical Rationalization Approach (Majid Khazaei, Ali Salehzadeh Nobari and M H Ferri Aliabadi)Problem of Detecting Damage Through Natural Frequency Changes (Gilbert-Rainer Gillich, Nuno N N Maia and Ion Cornel Mituletu)Damage Localization Based on Modal Response Measured with Shearography (J V Araújo dos Santos and H Lopes)Novel Techniques for Damage Detection Based on Mode Shape Analysis (Wieslaw Ostachowicz, Maciej Radzie?ski, Maosen Cao and Wei Xu)Damage Identification Based on Response Functions in Time and Frequency Domains (R P C Sampaio, T A N Silva, N M M Maia and S Zhong) Readership: Engineers, technicians, researchers working in the field of vibration-based techniques. Keywords: Structural Health Monitoring;SHM;Vibration-based SHM;Machine Learning;Time Domain Data Analysis;Frequency Domain Data Analysis;Damage IndexReview: Key Features: The 1st book to address theoretical,

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computational and experimental methods The book provides an up to date and comprehensive coverage of established and emerging techniques within the field of vibration-controlled damage detection Excellent balance between laboratory and practical applications Many case studies in various chapters that help the reader to identify weak and strong points of various techniques

This is the third volume of the very successful set. This updated volume will contain non-linear properties of some of the most useful materials as well as chapters on optical measurement techniques. * Contributors have decided the best values for n and k * References in each critique allow the reader to go back to the original data to examine and understand where the values have come from * Allows the reader to determine if any data in a spectral region needs to be filled in * Gives a wide and detailed view of experimental techniques for measuring the optical constants n and k * Incorporates and describes crystal structure, space-group symmetry, unit-cell dimensions, number of optic and acoustic modes, frequencies of optic modes, the irreducible representation, band gap, plasma frequency, and static dielectric constant

Handbook of Optical Metrology Principles and Applications, Second Edition CRC Press Handbook of Optical Systems, Metrology of Optical Components and Systems John Wiley & Sons

This work covers the history of optical communications, fibres and fiber cables, and compares optical fibres with other transmission media. It also discusses optical fibre

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materials, reliability and manufacture, illustrates the design, construction and properties of recent cables used for optical fibre, describes fibre splicing and presents automated fibre splicing machines, and more.

This book surveys the major and newly developed techniques for semiconductor strain metrology. Semiconductor strain metrology has emerged in recent years as a topic of great interest to researchers involved in thin film and nanoscale device characterizati

Handbook of Optical Sensors provides a comprehensive and integrated view of optical sensors, addressing the fundamentals, structures, technologies, applications, and future perspectives. Featuring chapters authored by recognized experts and major contributors to the field, this essential reference:

- Explains the basic aspects of optical sensors and the principles of optical metrology, presenting a brief historical review
- Explores the role of optical waveguides in sensing and discusses sensor technologies based on intensity and phase modulation, fluorescence, and plasmonic waves
- Describes wavefront sensing, multiphoton microscopy, and imaging based on optical coherence tomography
- Covers optical fiber sensing, from light guiding in standard and microstructured optical fibers to sensor multiplexing, distributed sensing, and fiber Bragg grating
- Offers a broad perspective of the field and identifies trends that could shape the future, such as metamaterials and entangled quantum states of light

Handbook of Optical Sensors is an ideal resource for practitioners and those seeking optical solutions for their specific needs, as well as for students and investigators who

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are the intellectual driving force of optical sensing.

This is an authoritative collection of data on the characteristics of materials & components of optical systems.

The state-of-the-art full-colored handbook gives a comprehensive introduction to the principles and the practice of calculation, layout, and understanding of optical systems and lens design. Written by reputed industrial experts in the field, this text introduces the user to the basic properties of optical systems, aberration theory, classification and characterization of systems, advanced simulation models, measuring of system quality and manufacturing issues. In this Volume Volume 2 continues the introduction given in volume 1 with the more advanced texts about the foundations of image formation.

Emphasis is placed on an intuitive while theoretically exact presentation. More than 400 color graphs and selected references on the end of each chapter support this undertaking. From the contents: 17 Wave equation 18 Diffraction 19 Interference and coherence 20 Imaging 21 Imaging with partial coherence 22 Three dimensional imaging 23 Polarization 24 Polarization and optical imaging A1 Mathematical appendix Other Volumes Volume 1: Fundamentals of Technical Optics Volume 3: Aberration Theory and Correction of Optical Systems Volume 4: Survey of Optical Instruments Volume 5: Advanced Physical Optics
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Due to their speed, data density, and versatility, optical metrology tools play important

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roles in today's high-speed industrial manufacturing applications. Handbook of Optical Dimensional Metrology provides useful background information and practical examples to help readers understand and effectively use state-of-the-art optical metrology methods. The book first builds a foundation for evaluating optical measurement methods. It explores the many terms of optical metrology and compares it to other forms of metrology, such as mechanical gaging, highlighting the limitations and errors associated with each mode of measurement at a general level. This comparison is particularly helpful to current industry users who operate the most widely applied mechanical tools. The book then focuses on each application area of measurement, working down from large area to medium-sized to submicron measurements. It describes the measurement of large objects on the scale of buildings, the measurement of durable manufactured goods such as aircraft engines and appliances, and the measurement of fine features on the micron and nanometer scales. In each area, the book covers fast, coarse measures as well as the finest measurements possible. Best practices and practical examples for each technology aid readers in effectively using the methods. Requiring no prior expertise in optical dimensional metrology, this handbook helps engineers and quality specialists understand the capabilities and limitations of optical metrology methods. It also shows them how to successfully apply optical metrology to a vast array of current engineering and scientific problems.

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